

Electronic Acknowledgement Receipt

EFS ID:	3215582
Application Number:	10690507
International Application Number:	
Confirmation Number:	6043
Title of Invention:	Method for manufacturing polycrystalline silicon thin film and thin film transistor fabricated using polycrystalline silicon thin film manufactured by the manufacturing
First Named Inventor/Applicant Name:	Ji Yong Park
Customer Number:	49455
Filer:	Hung H. Bui/Jennifer Oakley
Filer Authorized By:	Hung H. Bui
Attorney Docket Number:	1514.1032
Receipt Date:	28-APR-2008
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Application Type:	Utility under 35 USC 111(a)

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Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1		IDS_04-28-08.pdf	6153404	yes	70
			b22533a1ca50587854e9910c98e1cafb90c8198b		

Multipart Description/PDF files in .zip description			
Document Description		Start	End
Information Disclosure Statement Letter		1	4
Information Disclosure Statement (IDS) Filed		5	5
Foreign Reference		6	42
Foreign Reference		43	67
NPL Documents		68	70

Warnings:

Information:

Total Files Size (in bytes):	6153404
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.